

**METHOD OF FABRICATING POLYSILICON FILM BY EXCIMER LASER
CRYSTALLIZATION PROCESS**

Appl. No. : 10/604,687 Confirmation No. 1686
Applicant : Kun-chih Lin
Filed : August 11, 2003
TC/A.U. : 2822
Examiner : Maria Guerrero
Docket No. : ADTP0067USA0
Customer No. : 27765

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Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

- 5 Subject: Request for Continued Examination (RCE) in response to the Office
action dated 12/22/2004 and the Advisory action dated 03/11/2005

Dear Sir:

10 **INTRODUCTORY COMMENTS**

In response to the Office action and Advisory action identified above, the
above-identified application is to be amended as indicated in the following section.
Consideration of all amendments is politely requested.

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Amendments to the Claims are reflected in the listing of claims which begins on
page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.

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